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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/698,007	10/30/2003	2812	0.00	P05718 P05717	4	22	2

CONFIRMATION NO. 7412

23990
 DOCKET CLERK
 P.O. DRAWER 800889
 DALLAS, TX 75380

FILING RECEIPT



OC000000011794037

Date Mailed: 01/30/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Darren Lee Rust, Arlington, TX;
 George W. Logsdon, Arlington, TX;

Assignment For Published Patent Application

NATIONAL SEMICONDUCTOR CORPORATION, Santa Clara, CA;

Domestic Priority data as claimed by applicant

Foreign Applications

If Required, Foreign Filing License Granted: 01/29/2004

Projected Publication Date: Request for Non-Publication Acknowledged

Non-Publication Request: Yes

Early Publication Request: No

Title

Semiconductor wafer fabrication furnace idle monitor and method of operation

DOCKETED

FEB - 4 2004

RECEIVED

FEB - 4 2004

DAVIS MUNCK

Preliminary Class

438

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Title 35, United States Code, Section 184
Title 37, Code of Federal Regulations, 5.11 & 5.15**

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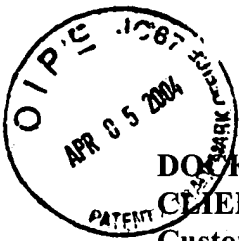
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DOCKET NO.: P05717
CLIENT NO.: NATI15-05717
Customer No. 23990

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : DARREN LEE RUST, ET AL.
U.S. Serial No. : 10/698,007
Filed : October 30, 2003
For : SEMICONDUCTOR WAFER FABRICATION FURNACE IDLE
MONITOR AND METHOD OF OPERATION
Group No. : 2812
Examiner : (Not Yet Assigned)

MAIL STOP MISSING PARTS

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Sir:

REQUEST FOR CORRECTED OFFICIAL FILING RECEIPT

In reviewing the file, it has been noted that the Official Filing Receipt contains a typographical error in the Attorney Docket Number. The Docket Number should be corrected to read as follows:

-- P05717--

DOCKET NO.: P05717
SERIAL NO. 10/698,007
PATENT

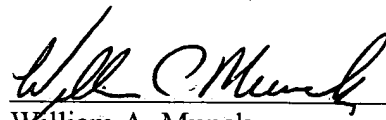
redlined copy of the Official Filing Receipt is attached. Once the correction is made, please forward a new filing receipt to the undersigned attorney at the below identified address.

Respectfully submitted,

DAVIS MUNCK, P.C.

Date:

March 30, 2004



William A. Munck

Registration No. 39,308

P.O. Drawer 800889

Dallas, Texas 75380

Tel.: (972) 628-3600

Fax: (972) 628-3616

E-mail: wmunck@davismunck.com